

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)	
KOROLIK et al.)	Group Art Unit: 1746
)	
)	Examiner: Heckert, Jason Mark
Application No.: 10/817,398)	
)	Docket No.: LAM2P467
Filed: April 1, 2004)	
)	Date: Oct. 2, 2008
For: CONTROLS OF AMBIENT)	
ENVIRONMENT DURING WAFER DRYING)	
USING PROXIMITY HEAD)	
_____)	

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Office Action dated July 2, 2008. The term for response extends to Oct. 2, 2008. Please enter this amendment.

Amendments to the claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.